



INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	Docket No. 52433/797	Application No. 10/535,346	
	Applicant(s) Tadashi ISHIKAWA et al.	Examiner SHEVIN, MARK L	
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U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*
	6,171,415	January 9, 2001	Statnikov			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	1-110707	04/27/1989	JP			Abstract corresponding to JP 1944370	
	1944370	06/23/1995	JP			Abstract corresponding to JP 1-110707	
	2002-220647	08/09/2002	JP			Abstract	
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	2003-113418	04/18/2003	JP			Abstract	

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EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	International Search Report dated 24 February 2004 issued in corresponding PCT Application No. PCT/JP03/14595.
	Kazuya YAMADA et al. "Cho Onpa Shot Peening ni yoru Zairyo Hyomenso no Nano-Kesshoka" The Japan Institute of Metals Koen Gaiyo, 2 November 2002, Vol. 131, page 265 [with English Translation]

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	